(FILE 'CA' ENTERED AT 07:59:29 ON 03 SEP 2002)
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FILE 'CA' ENTERED AT 07:59:55 ON 03 SEP 2002 376476 S SILICA OR SI203 L1L2 85498 S HYDROXYL L3 100768 S CMP OR CHEMIPOLISH? OR CHEMIMECH? OR PLANARIZ? OR LAP? OR GRI FILE 'REGISTRY' ENTERED AT 08:00:46 ON 03 SEP 2002 L41667 S SILICA/CNS FILE 'CA' ENTERED AT 08:00:52 ON 03 SEP 2002 33 S L1 AND L2 AND L3 L5 Lб 10 S L5 NOT L4 FILE 'JAPIO' ENTERED AT 08:01:37 ON 03 SEP 2002 L7 9 S L6 FILE 'INSPEC' ENTERED AT 08:02:12 ON 03 SEP 2002 r_8 3 S L6 FILE 'CA' ENTERED AT 08:02:41 ON 03 SEP 2002 L9 17 S L1(P)L2(P)L3 FILE 'USPATFULL' ENTERED AT 08:02:50 ON 03 SEP 2002 81 S L9 L10 SET HIGH OFF L1125 S L10 AND (SEMICONDUCT? OR WAFER# OR CHIP#) SET HIGH ON L1225 S L10 AND L11 8 S L12 AND (CMP OR CHEMIPOLISH? OR CHEMIMECH? OR PLANARIZ? OR LA L13 17 S L12 NOT L13 56 S L10 NOT L12 L15 0 S L15 AND (POLISH? OR CMP OR CHEMIPOLISH? OR CHEMIMECH? OR PLAN L16 3 S L15 AND (ABRAS? OR ABRAD?)/TI L17 L18 1 S L15 AND DENT?/TI L19 4 S L17 OR L18 FILE 'CA' ENTERED AT 08:08:45 ON 03 SEP 2002 L20 22 S L1 AND L2 AND POLISH? L21 3 S L20 NOT (L4 OR L6) FILE 'JAPIO' ENTERED AT 08:09:51 ON 03 SEP 2002 L22 4 S L21 FILE 'INSPEC' ENTERED AT 08:12:01 ON 03 SEP 2002 L23 0 S L21